



PCE/2825  
#  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akiro SATO

Group Art Unit: 2825

Application No.: 09/424,500

Examiner: G. Lee

Filed: February 22, 2000

Docket No.: 104788

For: METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE, MOLDING  
DEVICE FOR SEMICONDUCTOR DEVICE,  
AND SEMICONDUCTOR DEVICE

**MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RECEIVED  
JUL 17 2003  
TECHNOLOGY CENTER 2800

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination and entry and consideration of the Amendment After Final Rejection submitted on April 21, 2003. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 144081 in the amount of ☒ \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Linda M. Saltiel  
Registration No. 51,122

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01 FC:1601

750.00 DP

JAO:LMS/rxg

Date: July 11, 2003

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Alexandria, Virginia 22320  
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AUTHORIZATION  
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